INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 31, 2026

IGI Report Number	LG831659660
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	HEXAGONAL MODIFIED STEP CUT
Measurements	12.02 X 5.81 X 2.88 MM

GRADING RESULTS

Carat Weight	1.58 CARAT
Color Grade	F
Clarity Grade	VVS 2

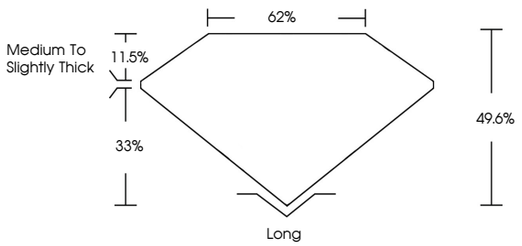
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG831659660

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG831659660
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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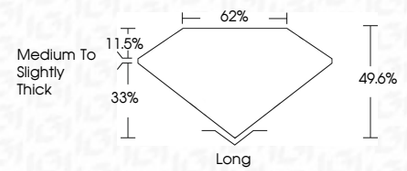
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IGI

August 31, 2026
IGI Report No LG831659660
HEXAGONAL MODIFIED STEP CUT
12.02 X 5.81 X 2.88 MM
Carat Weight 1.58 CARAT
Color Grade F
Clarity Grade VVS 2
Depth 49.6%
Table 62%
Girdle Medium To Slightly Thick
Culet Long
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG831659660
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Type IIa